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In re application of: Osamu Kobayashi

Attorney Docket No.: GENSP108

Application No.: 10/726,895

Examiner: Unassigned

Filed: December 2, 2003

Group: 2613

Title: MINIMIZING BUFFER REQUIREMENTS
IN A DIGITAL VIDEO SYSTEM

Confirmation No.: 4167

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on September 16, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: _____

Linda L. Pollock
Linda L. Pollock

**INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

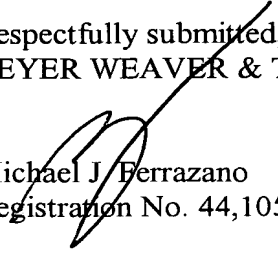
Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicant identifies these references in compliance with his duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure

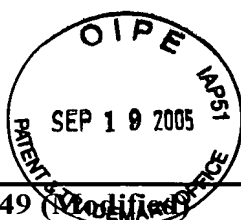
Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. GENSP108).

Respectfully submitted,
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Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty. Docket No. GENSP108	Application No.: 10/726,895
	Applicant: Osamu Kobayashi Filing Date December 2, 2003	Group 2613

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
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Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	A7	U.S. Office Action mailed August 9, 2005 from U.S. Application No. 10/726,438 (GENSP015)
	A8	U.S. Office Action mailed August 9, 2005 from U.S. Application No. 10/727,131 (GENSP104)
	A9	U.S. Office Action mailed August 5, 2005 from U.S. Application No. 10/726,934 (GENSP110)
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.